



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 2144

SERIAL NUMBER 10/733,431	FILING DATE 12/10/2003 RULE	CLASS 438	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 4717-5499
-----------------------------	-----------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Cecile Berne, Grenoble, FRANCE;

Bruno Ghyselen, Seyssinet-Pariset, FRANCE;

Chrystelle Lagahe, St. Joseph de Riviere, FRANCE; Thibaut Maurice, Grenoble, FRANCE;

** CONTINUING DATA ****

This appln claims benefit of 60/472,468 05/22/2003

verified . SP

** FOREIGN APPLICATIONS ****

EUROPEAN PATENT OFFICE (EPO) 02293049.9 12/10/2002

EUROPEAN PATENT OFFICE (EPO) 03292888.9 11/20/2003

verified SP

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/18/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	FRANCE	3	23	1
Verified and Acknowledged	Examiner's Signature  Initials 				

ADDRESS

28765

WINSTON & STRAWN LLP

1700 K STREET, N.W.

WASHINGTON , DC

20006

TITLE

Two-stage annealing method for manufacturing semiconductor substrates

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of
FILING FEE FEES: Authority has been given in Paper